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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Hachishiro IIZUKA

GROUP: 1792

SERIAL NO: 10/565,676

FILED: January 24, 2006

EXAMINER: CHEN, KEATH T

FOR: GAS REACTION SYSTEM AND SEMICONDUCTOR PROCESSING
APPARATUS

SUBMISSION OF SUPPLEMENTAL APPLICATION DATA SHEET

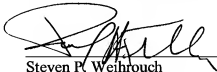
Office of Initial Patent Examination
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant(s) submit herewith a Supplemental Application Data Sheet for the above-identified application for the purpose of correcting the inventor's city of residence.

Respectfully Submitted,

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